

Docket No.: 50090-250

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kimio HAGI

Application No.: 09/732,891

Filed: December 11, 2000

For: ELECTROSTATIC CHUCKING SYSTEM, AND APPARATUS AND
METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE
USING THE ELECTROSTATIC CHUCKING SYSTEM

: Customer Number: 20277
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: Confirmation Number: 2930
:
: Group Art Unit: 2836 ✓
:
: Examiner: Isabel Rodriguez
:

REQUEST FOR RECONSIDERATION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks are submitted in response to the Office Action dated July 29, 2003.

REMARKS

At the time of the Office Action dated July 29, 2003, claims 2-8 were pending in this application. Applicant acknowledges, with appreciation, the Examiner's allowance of claims 2 and 5-8.

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